



PATENT NUMBER

U.S. UTILITY Patent Application

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	PATENT DAT	TE .

Farahmand Askarinam Robert Wu Jeremiah Pender Gerardo Delgadino  Top gas feed lid for semiconductor processing chamber	APPLICATION NO. 09/939332	CONT/PRIOR	CLASS 118	SUBCLASS	ART UNIT	EXAMINER
Gerardo Delgadino  Top gas feed lid for semiconductor processing chamber	. Robert W. Jeremiah	ł Pender	am .	<b></b>		Choweli
rop gas feed lid for semiconductor processing chamber	I Gerardo D I	elgadino		4		
	TOP gas t	eed lid 1	or semic	onductor p	rocessing	chamber
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	ISSUING	CLASSIFICATION
ORIGINAL	Araga Was	CPOSS REFERENCE(S)
CLASS SUBCLASS	CLASS	SUBCLASS (ONE SUBCLASS PER BLOCK)
INTERNATIONAL CLASSIFICATION		
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		3	CLAIMS ALLOWED
DISCLAIMER	Sheets Drwg. Figs. Drwg.	Print Fig.	Total Claims Print Claim for O.G
The term of this patent beequent to (date)		<del></del>	NOTICE OF ALLOWANCE MAILED
s been disclaimed.	(Assistant Examiner)	(Date)	
The term of this patent shall textend beyond the expiration date			
U.S Patent. No.			ISSUE FEE
			Amount Due Date Paid
STATE OF THE STATE	(Primary Examiner)	(Date)	
The terminalmonths of patent have been disclaimed.			ISSUE BATCH NUMBER
RNING:	(Legal Instruments Examiner)	(Date)	
	noted. Unauthorized disclosure may be	prohibited by the U	nited States Code Title 35, Sections 122, 181 and 388.